

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Sandhu et al.

Serial No.: 10/637,102

Filed: August 8, 2003

For: LOW RESISTANCE CONTACT TO SILICON HAVING A TITANIUM SILICIDE INTERFACE AND AN AMORPHOUS TITANIUM CARBONITRIDE BARRIER

LAYER

Confirmation No.: 5072

Examiner: L. Gurley

Group Art Unit: 2812

Attorney Docket No.: 2269-3264.7US

(92-0280.10/US)

Notice of Allowance Mailed:

May 14, 2004

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date

Deborah L. Hendricks Name (Type/Print)

AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)

Mail Stop ISSUE FEE Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

Please amend the above-referenced application as follows:

Astolater Alalagloy

Amendments to the Specification begin on page 3 of this paper.

Amendments to the Abstract appear on page 8 of this paper.

A Listing of the Claims begins on page 9 of this paper.

Remarks begin on page 14 of this paper.